IN THE UNITED STATES PATENT AND TRADEMARK O

In re the Application of:

Elkind et al.

Docket No.: TI-30785

Serial No:

TBD

Examiner: TBD

Filed:

10/25/01

Art Unit:

TBD

For:

ROBUST INTEGRATED SURFACE PLASMON RESONANCE SENSOR

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, DC 20231

Dear Sir:

Please make the references listed on the enclosed PTO-1449 of record under 37 C.F.R. 1.56, 1.97, and 1.98 in the patent application identified above. Copies of the listed references are enclosed.

Respectfully submitted,

Jacqueline J. Garner Attorney for Applicants Reg. No. 36,144

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	Substitute for Form 1449A/PTO	Application Number	TBD O		
INF	ORMATION DISCLOSURE	Filing Date	10/25/01		
	ATEMENT BY APPLICANT	First Named Inventor	Jerome L. Elkind		
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(use as many sheets as necessary)	Examiner Name	TBD 5 6		
Sheet	TI-30785	Attorney Docket No.	TI-30785 N		

				U.	S. PATENT DOCL	JMENTS T
	Cite No.1	U.S. Patent Document		Name of Patentee	Date of Pub.	
Exam. Initials*		Number	Kind Code ² (if known)	or Applicant of Cited Doc.	of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA	5,898,503		Keller et al.	04/27/99	
	AB	5,912,456		Melendez et al.	06/15/99	
	AC	5,946,083		Melendez et al.	08/31/99	
	AD	6,045,756		Carr et al.	04/04/00	
	AE	6,111,248		Melendez et al.	08/29/00	
	AF	6,111,652		Melendez et al.	08/29/00	
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	FOREIGN PATENT DOCUMENTS							
Exam. Initials*	Cite No.1	Foreign Patent Document			Name of Patentee	Date of Pub.		
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